



Contribution ID: 160

Type: not specified

**Laser ablation as a novel manufacturing technique
of high-precision 1D- and 2D-readout boards for
Micro-Pattern Gaseous Detectors (cancelled-included
in next talk)**

Tuesday, 7 May 2019 17:20 (20 minutes)

Presenter: AUNE, Stephan (CEA/IRFU,Centre d'étude de Saclay Gif-sur-Yvette (FR))